GAU | 3729

IN THE UNITED STATES PAFENT AND TRADEMARK OFFICE

In re the Application of: Tomoo IIJIMA 44122 2002

Serial Number: 09/466,895

3700 MAIL ROOM

Filed: December 20, 1999

Group Art Onit: 377

Examiner: S. SMITH

WIRING SUBSTRATE FOR MOUNTING SEMICONDUCTOR ELEMENTS AND FABRICATING METHOD THEREOF

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents Washington, D.C. 20231

Date: January 14, 2002

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated September 14, 2001 for one month from January 14, 2001 to January 14, 2002.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340. Two copies of this paper are enclosed herewith.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

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